

PATENT NUMBER and
ISSUE DATE

JC760 U.S. PTO
10/025322



2/18/01

U.S. UTILITY Patent Application

APPL NUM 10025322	FILING DATE 12/18/2001	CLASS 438	SUBCLASS GAU 2823	EXAMINER MALDONADO
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J6572
**APPLICANTS: Kusumoto Naoto; Takayama Toru; Yonezawa Masato;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/390,513 09/03/1999
WHICH IS A CON OF 09/735,554 10/23/1996 PAT 6,027,960

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 7-302189 10/25/1995

JAPAN 7-303138 11/01/1995

PG-18 DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO 0797/076003/US3130/3134D
Foreign priority claimed 35 USC 119 conditions met Initials and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no
TITLE : Laser annealing method and laser annealing device		

U.S. DEPT. OF COMM./PAT. & TM-PTO-438L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		Primary Examiner	
Amount Due	Date Paid	Total Claims	Print Claim 1 O.G.
TERMINAL		DRAWING	
		Sheets Drwg.	Figs. Drwg.
		Print	
		Application Examiner	